

**Reliability  
improvements of an  
electrostatic energy  
harvester for TPMS**



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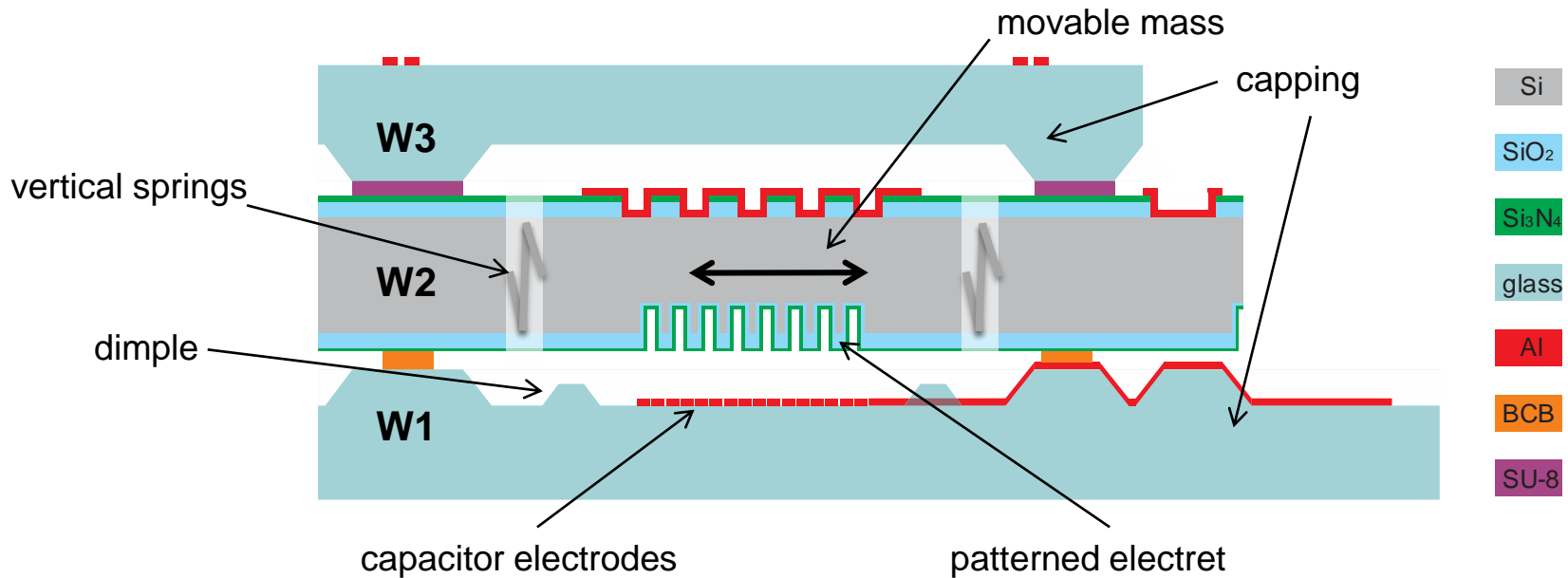
**Valve mounted**



**Tire integrated**

- Tire pressure monitoring system
  - Legislation driven market
- Transition from valve to tire → *intelligent tire*
  - All tire companies are developing intelligent tire solutions
    - Bridgestone, Pirelli, Continental, Goodyear,..
  - Added functionality besides pressure
    - Tire ID monitoring (ID, tire use (distance),..)
    - Safety improvements (coefficient of friction, tire wear,...)

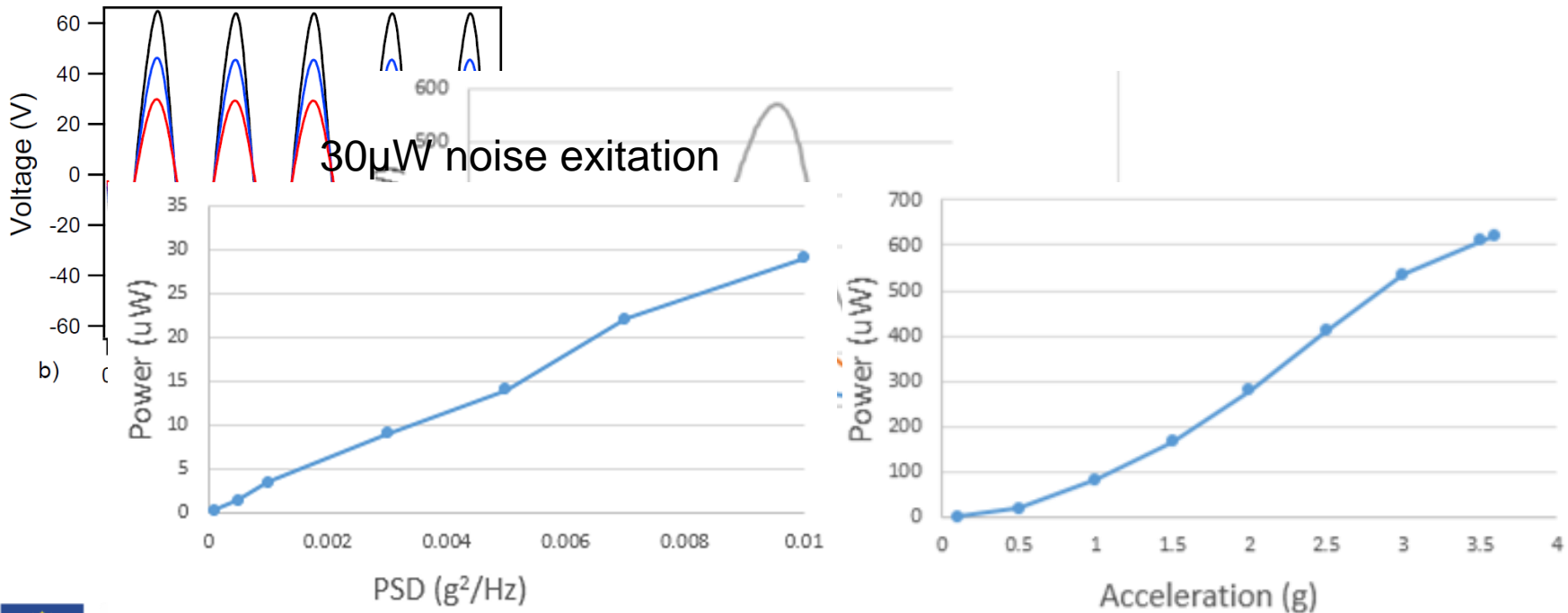




- **1<sup>st</sup> gen device design, materials, fabrication process**
  - Si mass on DRIE etched vertical springs
  - Corrugated DRIE etched Si with SiO<sub>2</sub>/Si<sub>3</sub>N<sub>4</sub> electret
  - Glass capping with cavity, dimples and electrodes
  - BCB or SU-8 polymer waferbond
  - Stepped dicing for access to electrodes

- Device characterisation 1<sup>st</sup> generation harvesters
  - Shaker with sinusoidal input

→ 600 $\mu$ W output power

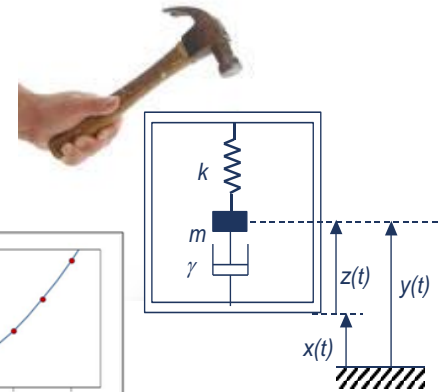


# Shock excitation inside tire

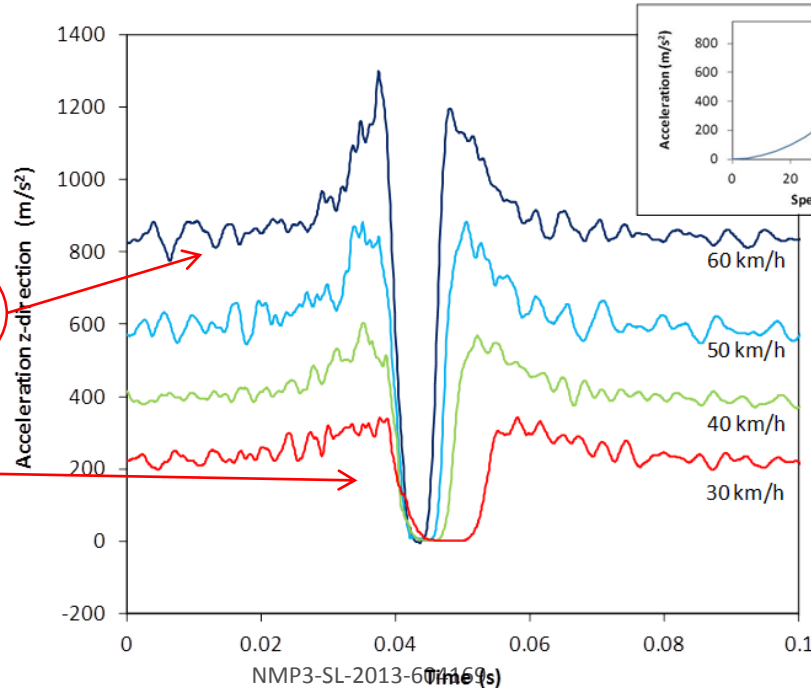
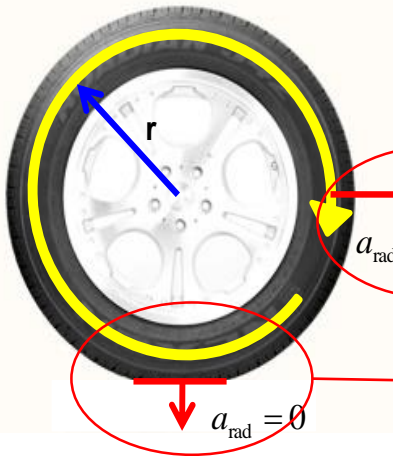


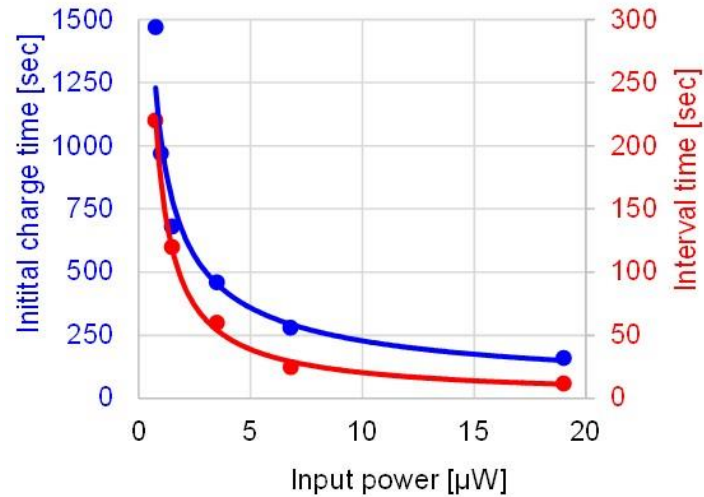
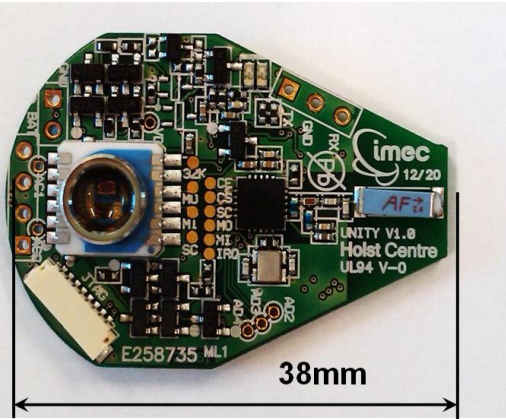
- Power generation by shock excitation
- Large shocks available inside tire
- Reliability is the main challenge!

Velocity damped resonator



Energy generation inside tire





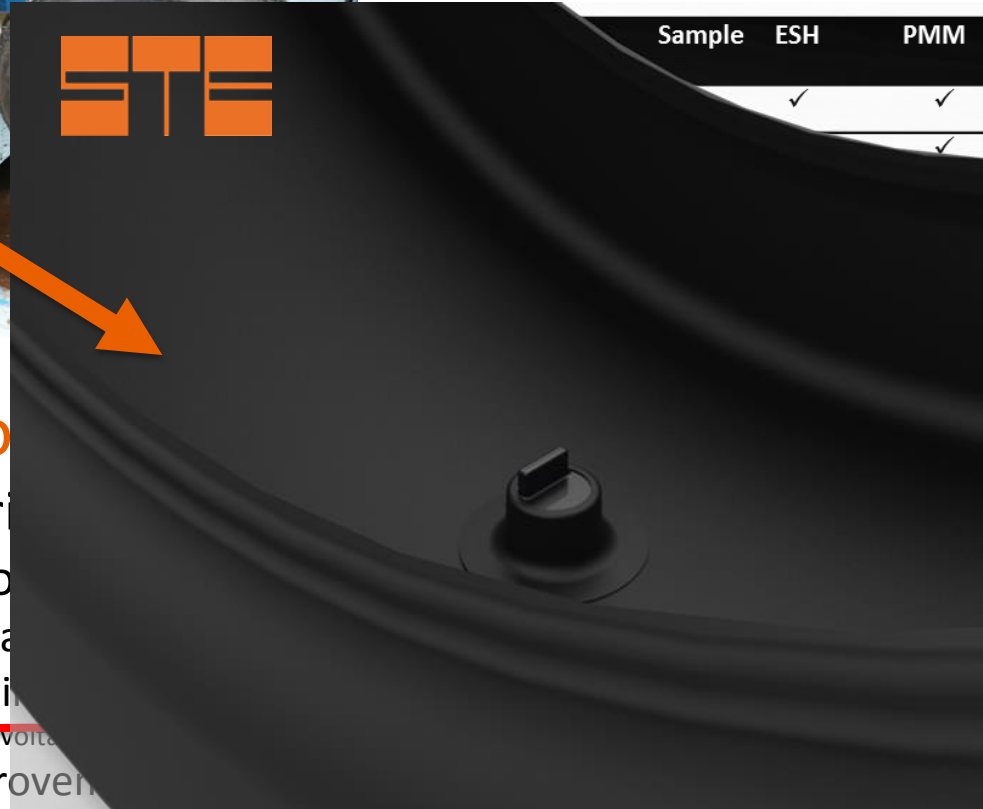
## TPMS SENSOR BOARD

- Off-the-shelf components
- Pressure and Temperature
- 2.4 GHz
- $\mu$ C : timing and data
- Charging from 0 Volts
- At 33 km/h, after 12 minutes  $\rightarrow$  transmissions
- 60 seconds interval  $\rightarrow$  3.5  $\mu$ W

Fully autonomous

Extreme low power

Small form factor

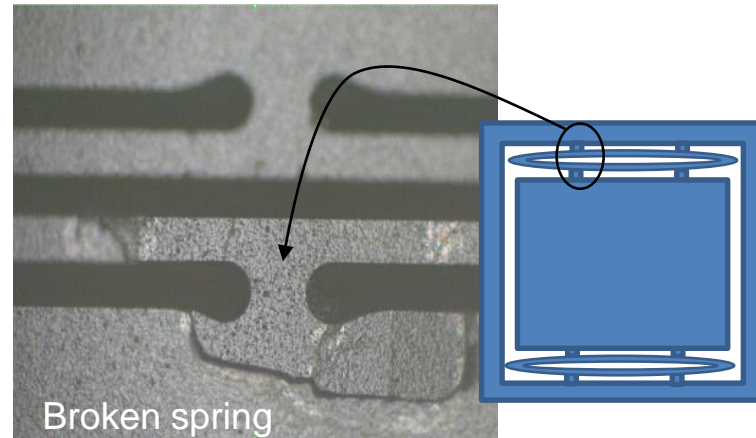
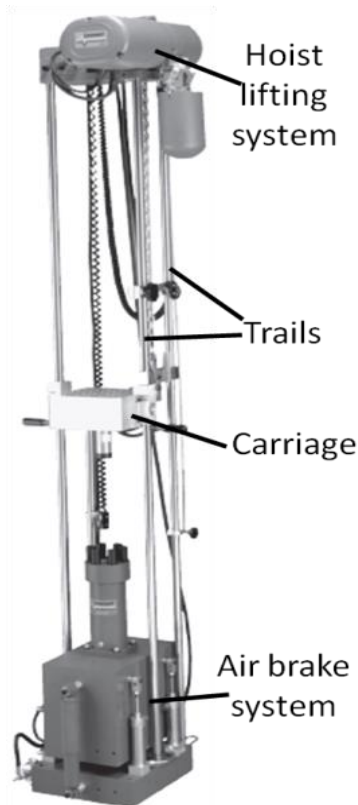


Sample	ESH	PMM	Sensor Board
	✓	✓	X
		✓	✓
			✓
			✓

## TPMS breakdo

- Harvesters: spring
  - 2<sup>nd</sup> generation
  - Optimized device architecture
  - Output power increase
    - Higher electroretrovo
  - Reliability improvement
    - Confine the mass movement (stoppers)
- Soldering connections → Better system integration needed

– Automotive standards requires components to survive high amplitude shocks\*

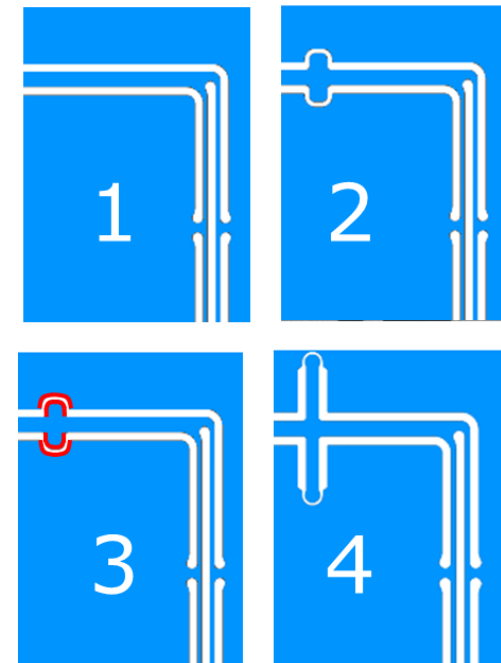
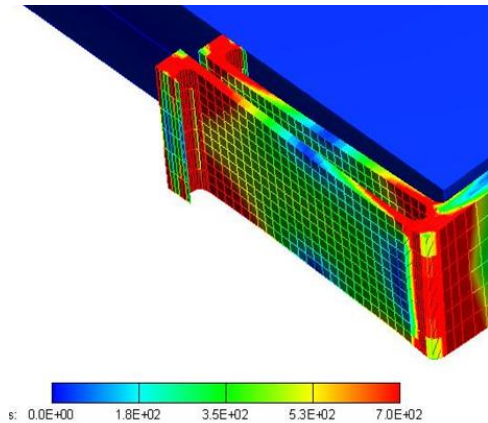


- Tests were carried out on a drop tester
  - Half sine profiles  $\sim 0.5\text{ms}$  up to 2500g
  - 100% survived  $> 2500\text{g}$  for best designs
- Several elements to improve the reliability of the harvester have been investigated:
  - Spring design improvements
  - Impact reduction by stoppers and soft coatings

\*JEDEC Standard Mechanical Shock JESD22-B104-B

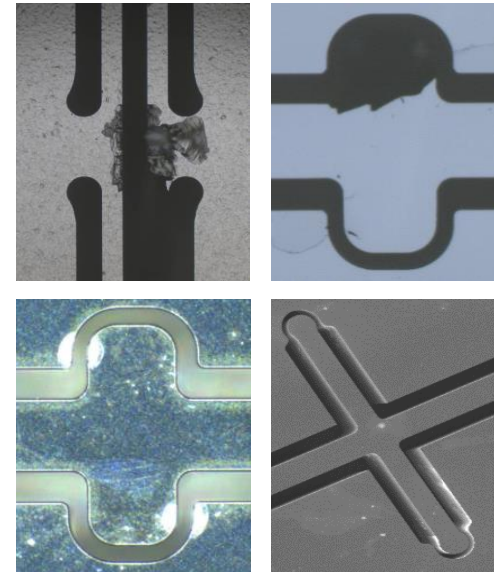
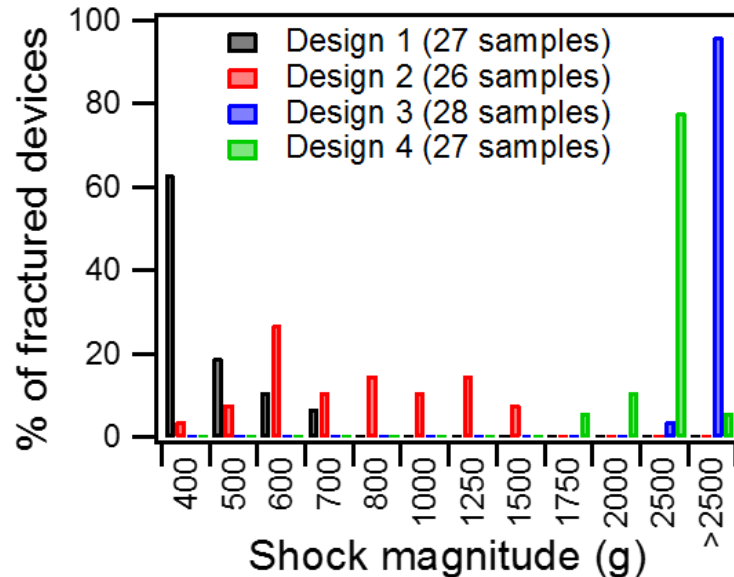


- Failure mode
  - Impact of anchor points
- Approach
  - Prevent / soften impact
- 4 designs
  - No stoppers
  - Rigid stoppers
  - Rigid stoppers with flexible coating
  - *Flexible stoppers*
- Drop tests
  - Shock acceleration up to 2500g

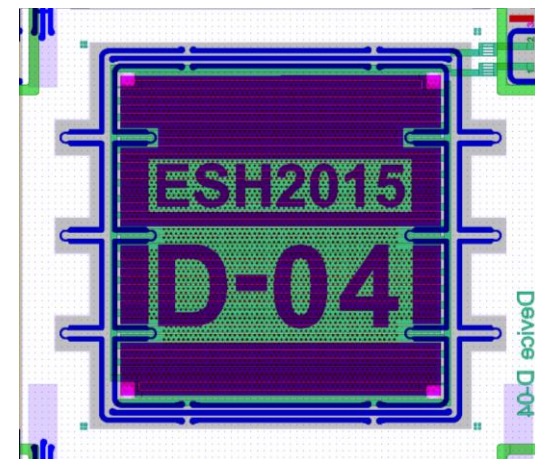
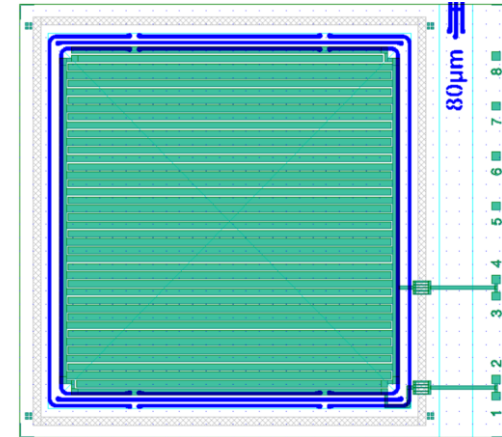


– Main failure mode: spring breakage → design improvements

- No stoppers: < 700g, break at anchors
- Rigid stoppers: <1500g, with large spread, breaks at stoppers
- Rigid stoppers with flexible coating: >2500g (drop tester limit)
- Flexible stoppers: > 2000g



- Device architecture
  - Flexible stoppers / shock absorbers
  - Deep W3 cavities with dimples
  - Improve waferbond
  - Elimination of stepped dicing
  
- Active part of harvester unchanged
  - Electret, electrodes, mass, springs



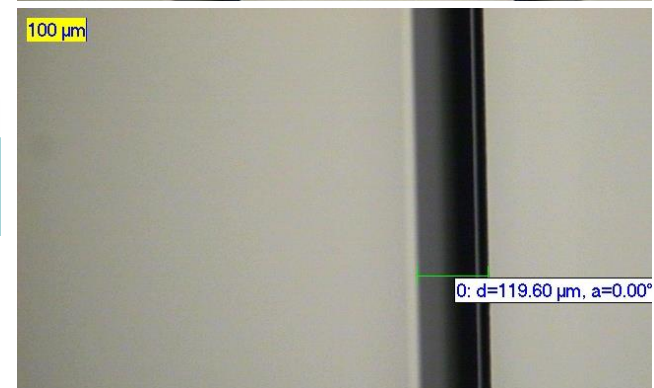
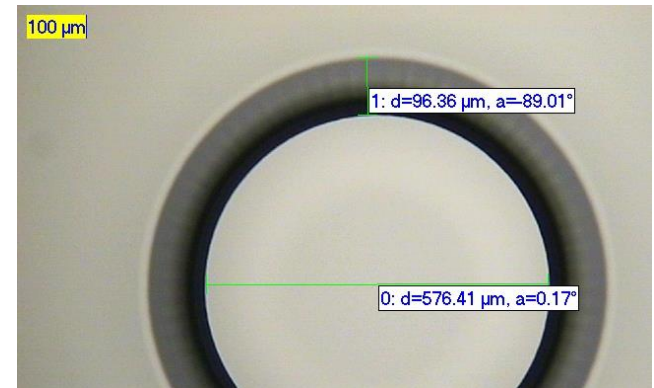
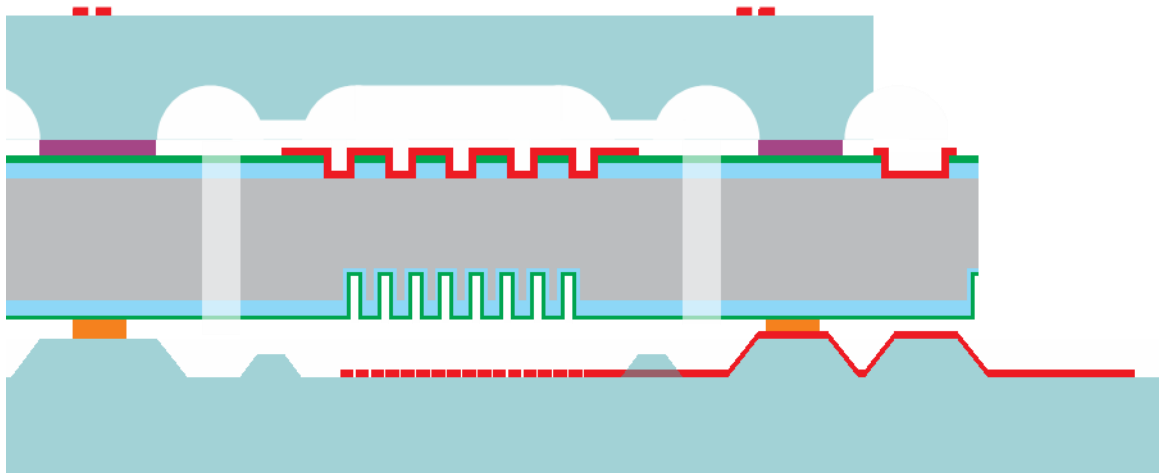
A 3D CAD model of a micro-machined device, likely a MEMS sensor or actuator. The model is shown in a perspective view, highlighting its complex, multi-layered structure. The device features a central rectangular cavity, a smaller cavity to the left, and a series of parallel channels on the right. Three yellow labels are overlaid on the model: 'Flexible stopper' points to a small, curved structure in the upper left; 'Spring' points to a long, thin, curved structure in the upper right; and 'Mass with Electret' points to a large, rectangular structure in the lower left.

Flexible stopper

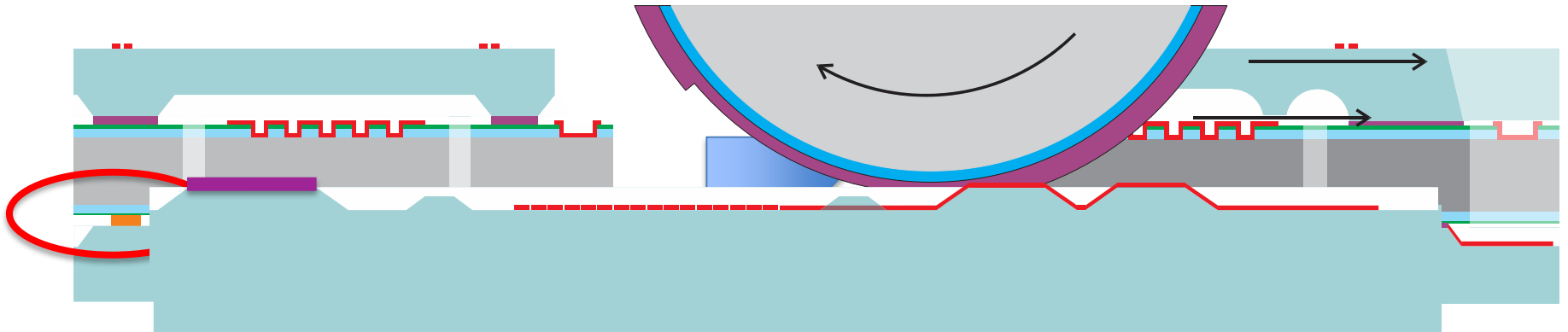
Spring

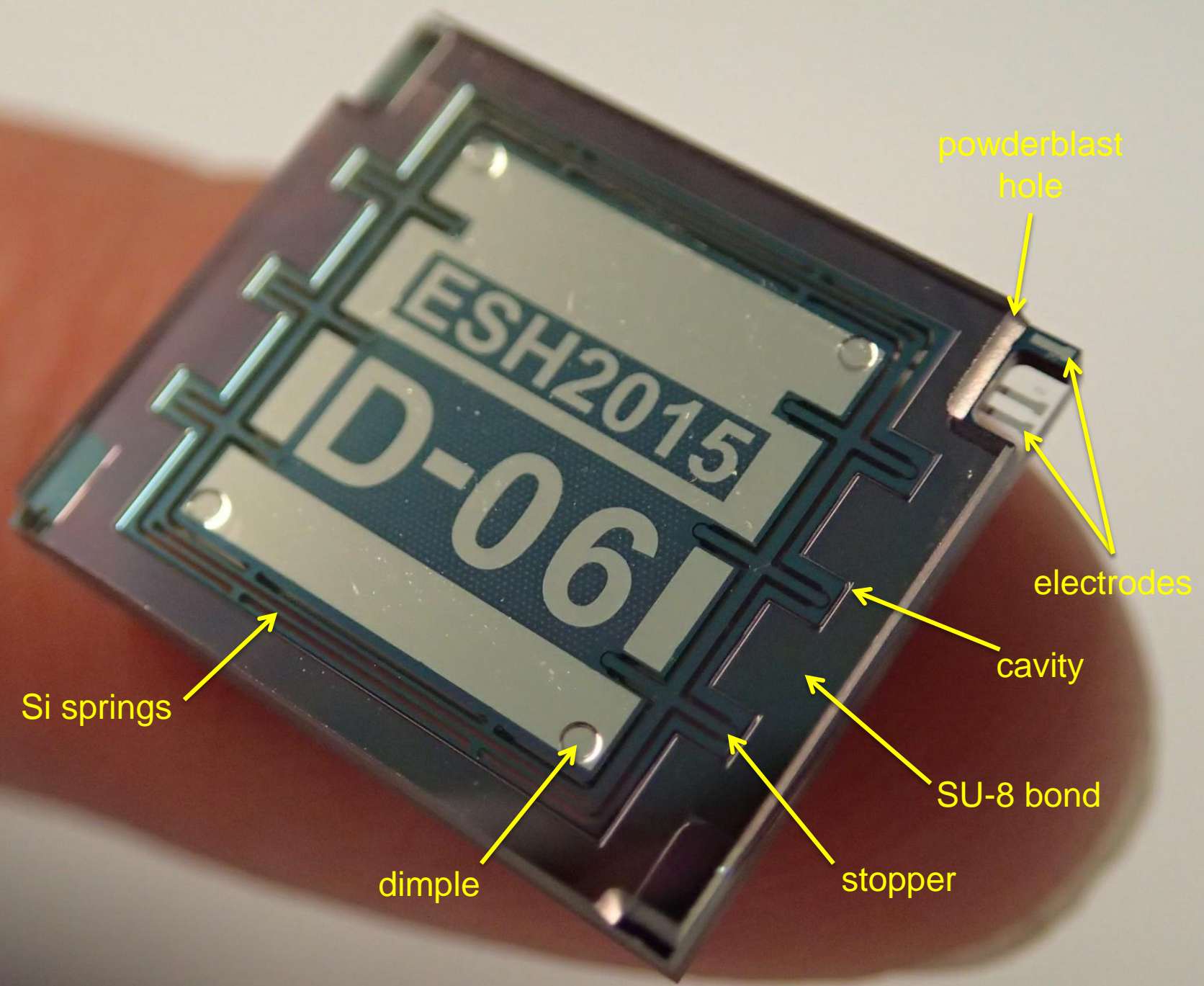
Mass with Electret

- Deep W3 cavities with dimples
  - Restricted out-of-plane movement
  - No extra air damping
  - 2-step HF etching process



- Improved W1-W2 waferbond
- Increase waferbond area
- Replace BCB by SU-8
  - Larger BCB bond area would need higher bond pressure
  - SU-8 bond is thinner → more hermetic





powderblast hole

electrodes

cavity

SU-8 bond

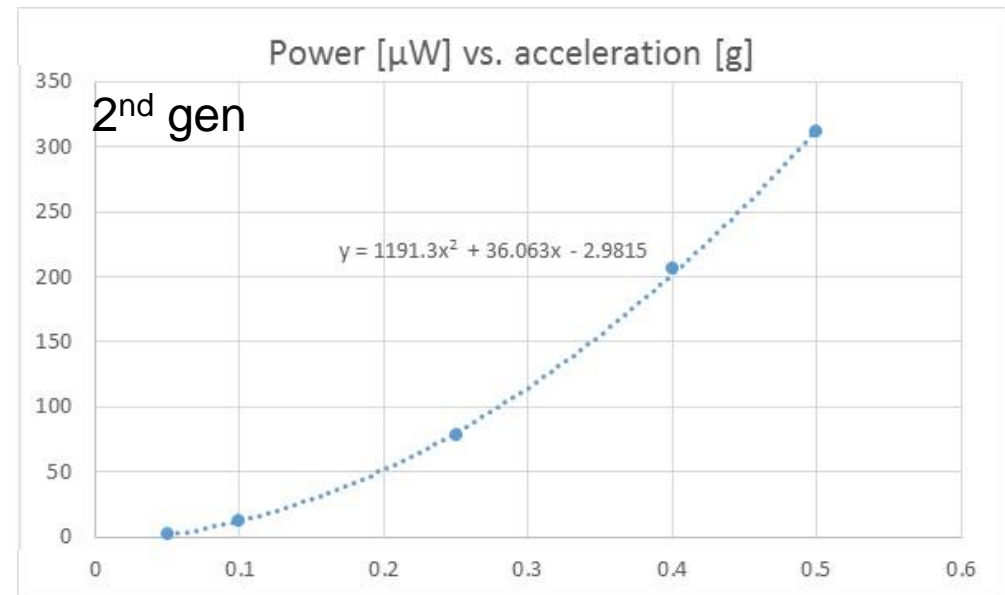
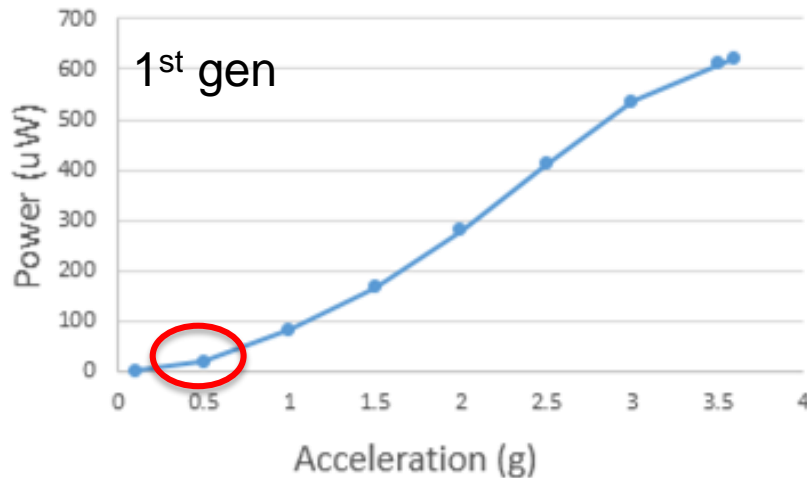
stopper

Si springs

dimple

ESH2015  
ID-061

- Device from wafer edge → electret voltage 140V
  - Quadratic relation power vs. acceleration → OK
  - Very sensitive 1200  $\mu\text{W}/\text{g}^2$  → higher than 1<sup>st</sup> gen (50  $\mu\text{W}/\text{g}^2$ )
  - Very high Quality factor  $\sim 500$  → higher than 1<sup>st</sup> gen ( $\sim 150$ )
  - Max power  $\sim 300 \mu\text{W}$  at 0.5g → lower than 1<sup>st</sup> gen (600  $\mu\text{W}$ )





- Electrostatic energy harvesters with electret show high power output → up to  $600\mu\text{W}$
- Shock excitation in tire delivers sufficient power for TPMS
- Robustness improved with flexible stoppers
- Improved wafer level bonding with SU-8
  - Better bond and hermiticity (lower damping losses)
- Next step: *integration in a robust TPMS module*

***Devices are very promising for integration in TPMS***

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